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December 15, 2003

RECEIVED**DEC 29 2003****TC 1700**

Mail Stop Non-Fee AMENDMENT
 Commissioner For Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Re: Applicant(s): Woo Sik Yoo
 Assignee: WaferMasters, Inc.
 Title: Method Of Forming An Oxide Layer (As Amended)
 Serial No.: 10/085,498
 Examiner: Kirsten Jolley
 Docket No.: M-11549 US
 Filed: February 26, 2002
 Group Art Unit: 1762

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter; and
- (3) Response to Office Action (12 pages).



No additional fee is required.



The fee has been calculated as shown below:

CLAIMS AS AMENDED

	Claims Remaining After Amendment		Highest No. Previously Paid For		Present Extra	Rate	Additional Fee
Total Claims	20	Minus	31	=	0	x \$18.00	\$ 0
Independent Claims	2	Minus	5	=	0	x \$84.00	\$ 0
<input type="checkbox"/>	Fee of _____ for the first filing of one or more multiple dependent claims per application						\$
<input type="checkbox"/>	Fee for Request for Extension of Time						\$

Total additional fee for this Amendment:

\$



Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.



Please charge our Deposit Account No. 50-2257 in the amount of \$



Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257

Total: \$0

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450, on December 15, 2003.

Sandy Kim

December 15, 2003

Respectfully submitted,

Theodore P. Lopez
 Attorney for Applicants
 Reg. No. 44,881



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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TC 1700

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Assignee: WaferMasters, Inc.

Title: METHOD OF FORMING AN OXIDE LAYER (As Amended)

Serial No.: 10/085498

Filing Date: February 26, 2002

Examiner: Jolley, Kirsten

Group Art Unit: 1762

Docket No.: M-11549 US

Irvine, California
December 15, 2003

RESPONSE TO NON-FINAL OFFICE ACTION

Dear Sir:

In response to the Office Action dated September 15, 2003, Applicants submit the following amendments and remarks.